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KENYON & KENYON

One Broadway New York, New York 10004

TO:

Examiner Allan Olsen

FAX NO:

(571) 273-1441

DATE:

March 18, 2004

FROM:

R. L. Mayer, Esq.

NO. OF PAGES INCLUDING COVER: 16

Please call (212) 425-7200 Ext. 322, if any pages were not received or are illegible.

MESSAGE:

Re: US Application Serial No. 09/889,838

Inventors: F. Laermer et al.

Filed: 1/24/2002

Docket No.: 10191/1808

As requested, attached please find the response to office action of July 30, 2003 and postcard.

The information contained in this facsimile message is attorney privileged and confidential information intended only for the use of the recipient named above. If you are not the intended recipient, or the person responsible to deliver it to the intended recipient, you are notified that any dissemination, distribution or copying of this communication is strictly prohibited. If you have received this first csimile in error, please immediately notify us by telephon, and return the original and all copies to us at the above address.

Case No. 10191 1808 Ser. No. 09/899, 888	Atty. CAO Dere Date 19/103
The Impressed Mail Room	date stamp acknowledges receipt of the
□ Application	Extension Request
Amendment	☐ Priority Document
☐ Assignment	☐ Issue Fee
☐ Notice of Appeal	☐ Declaration \
☐ Prior Art Statement	Small Entity
Appeal Brief	Drey 101 consones
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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

AMENDMENT TRANSMITTAL LETTER		Docket Number 10191/1808		
Application Number 09/889,838	Filing Date January 24, 2002	Examiner Allan Olsen	Art Unit 1763	
Invention Title PLASMA ETCHING METHOD HAVING PULSED SUBSTRATE ELECTRODE POWER		Inventor(s) Franz LAERMER et al.		

Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on:

Date: December 2003

Transmitted herewith is an Amendment for entry in the above-identified application.

The filing fee has been calculated as shown below:

I. Inching	TOO HOD OOOH OW	***********	D210 11 11 0 010 11 1	·		
	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR	PRESENT NUMBER EXTRA	RATE (\$)	FEE (\$)
TOTAL CLAIMS	39	minus	20	19	18.00	342.00
INDEPENDENT CLAIMS	4	minus	3	1	86.00	86.00 ⁻
MULTIPLE DEPENDENT CLAIM ADDED					290.00	
					TOTAL	428.00
				TOTAL DUE	(small entity)	428.00

2. Please charge the additional claims fee of \$428.00 to the deposit account of Kenyon & Kenyon, deposit account number 11-0600.

U.S. PAT	DEPARTMENT OF ENT AND TRADEM	COMMERCE ARK OFFICE		
REQUEST FOR CORRECT RECEIPT	Docket Number: 10191/1808			
Application Number 09/899,838	Filing Date January 24, 2002	Examiner Allan Olsen	Art Unit 1763	
Invention Title PLASMA ETCHING METHOD SUBSTRATE ELECTRODE PO	Inventor(s) Franz LAERMER et al.			

Address to:

Commissioner of Patents

P.O. Box 1450

Alexander, VA 22313-1450

Applicants respectfully request that the filing receipt (a copy of which is attached) be corrected to show the title and the attorney docket no. to read:

PLASMA ETCHING METHOD HAVING PULSED SUBSTRATE ELECTRODE POWER

10191/1808

Please issue a corrected filing receipt as requested above. If any fees are due they should be charged to Kenyon & Kenyon Deposit Account No. 11-0600.

Dated: Decomo 1,2003 By:

Richard L. Mayer (Reg. No/22,490)

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